

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention**ISOLATED FULLY DEPLETED SILICON-ON-INSULATOR REGIONS BY
SELECTIVE ETCH**

Application Number:

Confirmation Number:

First Named Applicant: Matthew Breitwisch

Attorney Docket Number: BUR920040015US1

Search string: (5306659 or 5324683 or 5391911 or 6020250 or 6492705).pn.

US Patent Documents**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

| init | Cite.No. | Patent No. | Date | Patentee | Kind | Class | Subclass |
|------|----------|------------|------------|--------------|------|-------|----------|
| | 1 | 5306659 | 1994-04-26 | Beyer et al | | | |
| | 2 | 5324683 | 1994-06-08 | Fitch et al | | | |
| | 3 | 5391911 | 1995-02-21 | Beyer et al | | | |
| | 4 | 6020250 | 2000-02-01 | Kenny | | | |
| | 5 | 6492705 | 2002-12-10 | Begley et al | | | |

Signature**Examiner Name****Date**